

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,878,507 B2  
APPLICATION NO. : 09/885393  
DATED : April 12, 2005  
INVENTOR(S) : Richard D. Holscher, Zhiping Yin and Thomas R. Glass

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Page, item [56]:

Pg. 3, col. 2, - Other Publications

Insert --Abstract: Loboda, M. et al., "Using Trimethylsilane to Improve Safety, Throughput and Versatility in PECVD Processes", Electrochemical Society Mtg., #358, Montreal, Quebec, Vol. MA 97-1, 1997, pg. 454--

Pg. 3, col. 2, - Other Publications

Insert --Julius Grant, "Hack's Chemical Dictionary", McGraw-Hill Book Co., 1969, Fourth Ed., pg. 27--

Signed and Sealed this

Twelfth Day of August, 2008

A handwritten signature in black ink, reading "Jon W. Dudas". The signature is stylized, with a large, looped initial "J" and a distinct "D" at the end.

JON W. DUDAS  
*Director of the United States Patent and Trademark Office*